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Substitute for form 1449A/B/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Complete if Known	
				Application Number	10/665,099-Conf. #6145
				Filing Date	September 17, 2003
				First Named Inventor	Cem Basceri
				Art Unit	2823
				Examiner Name	W. M. Brewster
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-11/027,825	Filed 12-29-2004	Derderian et al.	
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		US-10/814,573	Filed 03-31-2004	Gealy et al.	
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				Application Number	10/665,099-Conf. #6145
				Filing Date	September 17, 2003
				First Named Inventor	Cem Basceri
				Art Unit	2823
				Examiner Name	W. M. Brewster
Sheet	10	of	13	Attorney Docket Number	108298719US

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Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
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NON PATENT LITERATURE DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				T ²
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